

Title (en)

Reverse pulse plating method

Title (de)

Methode zum Elektroplattieren mit Umkehrpulsstrom

Title (fr)

Méthode pour placage électrolytique utilisant du courant pulsé inversé

Publication

EP 1475463 B2 20170301 (EN)

Application

EP 03258024 A 20031218

Priority

US 43597602 P 20021220

Abstract (en)

[origin: EP1475463A2] A composition and method for electroplating a metal on a substrate. The composition has a chloride to brightener concentration ratio of from 20:1 to 125:1. The method of electroplating, which employs the composition, employs pulse patterns that improve physical properties of metal surfaces.

IPC 8 full level

C25D 3/02 (2006.01); **C25D 3/38** (2006.01); **C25D 5/18** (2006.01); **C25D 7/00** (2006.01)

CPC (source: EP KR US)

C25D 3/02 (2013.01 - EP KR US); **C25D 3/38** (2013.01 - EP US); **C25D 5/18** (2013.01 - EP US)

Citation (opposition)

Opponent :

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DE FR GB

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EP 03258024 A 20031218; CN 200310124974 A 20031219; DE 60336539 T 20031218; JP 2003423400 A 20031219; KR 20030093625 A 20031219; TW 92136071 A 20031219; US 29004005 A 20051130; US 74190803 A 20031219